## Notice of References Cited Application/Control No. 10/576,170 Examiner JOHN LEE Applicant(s)/Patent Under Reexamination MILOV ET AL. Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,715,108 A	02-1998	Yoo, Hang-du	360/62
*	В	US-6,203,425 B1	03-2001	Hayashi, Shinobu	463/1
*	O	US-2002/0156829 A1	10-2002	Yoshimine, Takao	709/201
*	D	US-2003/0172374 A1	09-2003	Vinson et al.	725/9
*	ш	US-7,478,182 B2	01-2009	Schweig, Marc E.	710/73
*	F	US-7,617,299 B2	11-2009	Yoshimine, Takao	709/219
*	G	US-2010/0138360 A1	06-2010	Cutler et al.	705/36.R
	Ι	US-			
	_	US-			
	٦	US-			
	K	US-			
	┙	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν					
	0					
	Р					
	Ø					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U	Redstone Software, Inc.,"Software Automation and Testing," 27 June 2004, XP002383091, pages 1-19					
	٧						
	w						
	х						

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.